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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

DeVries, et al.

Serial No.: 10/709,325

Group Art Unit: 2811

Filed: April 4, 2004

Examiner: Im, J.

For: METHOD AND STRUCTURE FOR CONNECTING GROUND/POWER NETWORKS
TO PREVENT CHARGE DAMAGE IN SILICON ON INSULATOR

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action dated January 23, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.